## Application/Control No. Applicant(s)/Patent Under Reexamination 10/612,760 CHEN ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 David E. Martinez 2181 **U.S. PATENT DOCUMENTS Document Number** Date Name Classification Country Code-Number-Kind Code MM-YYYY \* US-2004/0097215 05-2004 Abe et al. Α 455/403 US-В US-С US-D US-Ε US-F US-G US-Н US-1 US-J US-Κ US-L US-М **FOREIGN PATENT DOCUMENTS Document Number** Date Country Code-Number-Kind Code Country Name Classification MM-YYYY Ν 0 Р Q R S T **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U ٧

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